## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Confirmation No.: 8564

Yutaka NISHIOKA et al.

Art Unit: 1715

Application No.: 10/569,470

Examiner: Mandy C. LOUIE

Filed: October 20, 2006

Attorney Dkt. No.: 026390-00034

Date: November 28, 2011

For: APPARATUS FOR PREPARING OXIDE THIN FILM AND METHOD FOR

PREPARING THE SAME

## RESPONSE UNDER 37 C.F.R § 1.111

## MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the outstanding Office Action dated June 28, 2011, the period for response is extended two months, from September 28, 2011, to November 28, 2011, with payment of the appropriate fees, please amend the application as shown on the following pages:

Amendments to the Claims begin on page 2.

Remarks/arguments begin on page 6.